Oocket No.: 005918 USA/FPS/MMCS/APC PATENT/OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

RECEIVED

SHANMUGASUNDRAM et al.

Serial No. 09/943,955

Group Art Unit: 2122

Technology Center 2100

Filed: August 31, 2001

Examiner:

For:

FEEDBACK CONTROL OF A CHEMICAL MECHANICAL POLISHING DEVICE

PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed documents is material or constitutes prior art. If it should be determined that any of the listed documents does not constitute prior art under the United States law, Applicants reserve the right

Serial No. 09/943,955

to present to the Office the relevant facts and law regarding the appropriate status of such document.

No certification or fee is believed to be required. However, the Commissioner is hereby authorized to charge any additional fees should any be required for this submission, or credit any overpayment to deposit account no. 08-0219.

Respectfully submitted,

HALE AND DORR LLP

Scott M. Alter

Registration No. 32,879

Reston Town Center 11951 Freedom Drive

Reston, VA 20190

TEL (703) 654-7021 SMA/mgm

FAX (703) 654-7100

Date: 10/9/03

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				APPLICANT SHANMUGASUNDRAM		SERIAL NO. 09/943,955			
				FILING DATE August 31, 2001		GROUP 2122			
		U	.S. PATENT D	OCUMENTS					
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME CLA			SUBCLASS	FILING DATE		
	5,901,313	05/04/99	Wolf et al.				09/02/	97	
	6,002,989	12/14/99	Shiba et al.			/FD	04/01/97		
	6,094,688	07/25/00	Mellen-Garne		CEIV	VED	03/12/98		
	6,340,602	01/22/02	Johnson et al.	۵	CT 1 0	2003			
_	6,345,288	02/05/02	Reed et al.	-		05/15/00			
	6,368,879	04/09/02	Toprac Technology Center 2100 09/22/99				99		
	US-2002/0107604	08/08/02	Riley et al.				12/06/00		
·	6,470,230	10/22/02	Toprac et al.				01/04/00		
	6,482,660	11/19/02	Conchieri et a	1.			03/19/01		
	6,567,717	05/20/03	Krivokapic et	okapic et al. 01/			01/19/	01/19/00	
		FOR	EIGN PATEN	T DOCUMENTS			Same and Special		
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Translation		
IMITIALS					CLASS		Yes	No	
	WO 99/59200	11/18/99	WIPO				X		
	WO 01/52319	07/19/01	WIPO	•			X		
**									
	OTHER	ART (Inclu	ding Author,	Title, Date, Pertinent	Pages, Etc	c.)			
	Shanthikumar. Octo Manufacturing Con Piscataway, NJ. pp.	ber 1999. "C ference Proc 43 - 46.	Optimized Samp ceedings, 1999 I	Ionahan, Raman Nuran ble Planning for Wafer EEE International Syn	Defect Ins	spection," Sem n Santa Clara,	iconduc CA.		
	23 July 2003. Invitation to Pay Additional Fees and Communication Relating to the Results of the Partial International Search for PCT/US02/19116.								
	01 August 2003. W			01/27406.					
	20 August 2003. Written Opinion for PCT/US01/22833.								
EXAMINER	DATE CONSIDERED								

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.